

FORM PTO - 1449 INFORMATION DISCLOSURE STATEMENT				ATTY DOCKET NO.: QCS-003DV APPLICANT: Kamieniecki SERIAL NO.: Not yet assigned FILING DATE: October 10, 2001 GROUP: Not yet assigned 2881				
U.S. PATENT DOCUMENTS								
EXAM. INIT.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE		
<div style="font-size: 2em; margin-bottom: 10px;">A</div> <div style="font-size: 2em;">11/15</div>	4,544,887	10/01/85	Kamieniecki	324	158	10/21/82		
	4,558,660	12/17/85	Nishizawa et al.	118	725	3/16/83		
	4,581,578	04/08/86	Honma et al.	324	158	01/31/84		
	4,599,558	07/08/86	Castellano, Jr. et al.	324	158	12/14/83		
	4,871,417	10/3/89	Nishizawa et al.	156	640	6/30/87		
	5,306,671	04/26/94	Ogawa et al.					
	5,453,702	09/26/95	Goldfarb	324	765	11/29/93		
	5,470,799	11/28/95	Itoh et al.	437	238	4/24/89		
	5,471,293	11/28/95	Lowell et al.	356	30	02/02/94		
	5,663,657	09/02/97	Lagowski et al.	324	766	09/26/94		
	5,661,408	08/26/97	Kamieniecki et al.	324	765	03/01/95		
	5,716,495	2/10/98	Butterbaugh et al.	156	643.1	3/25/96		
FOREIGN PATENT DOCUMENTS								
EXAM. INIT.	DOCUMENT NUMBER	DATE	COUNTRY CODE	CLASS	SUB CLASS	FILING DATE	ABSTRACT ONLY	ENGLISH LANG Y/N
<div style="font-size: 2em; margin-bottom: 10px;">11/15</div> <div style="font-size: 2em;">11/15</div>	41 22 587	01/23/93	DE					N
	WO 94/23854	10/27/94	PCT					Y
OTHER ART, JOURNAL ARTICLES, ETC.								
EXAM. INIT.	OTHER DOCUMENTS: (Including Author, Title, Date, Relevant Pages, Place of Publication)							
<div style="font-size: 2em; margin-bottom: 10px;">11/15</div> <div style="font-size: 2em;">11/15</div>	Akazawa et al., "Photostimulated Evaporation of SiO ₂ and Si ₃ N ₄ Films by Synchrotron Radiation and its Application for Low-Temperature Cleaning of Si Surfaces", <i>Journal of Vacuum Science and Technology</i> , Vol. 9, No. 5, September 1, 1991, pp. 2653-2661							
EXAMINER <i>Michael Wells</i>				DATE CONSIDERED <i>June 24, 2004</i>				

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FOOTNOTES



SHEET 1 OF 1

FORM PTO - 1449 SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT				ATTY DOCKET NO.: QCS-003DV APPLICANTS: Kamieniecki et al. SERIAL NO.: 09/974,024 FILING DATE: October 10, 2001 GROUP: 2820 2881					
U.S. PATENT DOCUMENTS									
EXAM. INIT.		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE		
<i>HW</i>		A13 3,850,508	11/26/74	Sittig et al.	356	209	11/14/72		
<i>HW</i>		A14 4,824,698	4/25/89	Jastrzebski et al.	427	255	12/23/87		
<i>HW</i>		A15 5,216,362	6/1/93	Verkuil	324	158	10/8/91		
<i>HW</i>		A16 5,581,194	12/3/96	Lowell	324	752	6/7/95		
<i>HW</i>		A17 5,977,788	11/2/99	Lagowski	324	765	7/11/97		
<i>HW</i>		A18 6,166,354	12/26/00	Hause et al.	219	390	6/16/97		
<i>HW</i>		A19 6,326,220	12/4/01	Chen et al.	438	14	11/11/00		
EXAMINER <i>Nicholas Kelly</i>				DATE CONSIDERED <i>June 22, 2004</i>					
FOREIGN PATENT DOCUMENTS									
EXAM. INIT.		DOCUMENT NUMBER	DATE	COUNTRY CODE	CLASS	SUB CLASS	FILING DATE	ABSTRACT ONLY	ENGLISH LANG Y/N
OTHER ART, JOURNAL ARTICLES, ETC.									
EXAM. INIT.	OTHER DOCUMENTS: (Including Author, Title, Date, Relevant Pages, Place of Publication)								
EXAMINER					DATE CONSIDERED				

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